

**Electronic Filing System (EFS) Data**  
**Electronic Patent Application Submission**  
**USPTO Use Only**

EFS ID:	62493	
Application ID:	10710023	
Title of Invention:	LITHOGRAPHIC SEMICONDUCTOR MANUFACTURING USING A MULTI-LAYERED PROCESS	
First Named Inventor:	Philip Lamarre	
Domestic/Foreign Application:	Domestic Application	
Filing Date:	2004-06-14	
Effective Receipt Date:	2004-06-14	
Submission Type:	Utility Patent Filing	
Filing Type:	new-utility	
Confirmation number:	4022	
Attorney Docket Number:	20030146	
Total Fees Authorized:	810.0	
Payment Category:	Deposit Account	
Deposit Account Number:	190130	
Deposit Account Name:	Scott J. Asmus	
Access Code:	****	
RAM Payment Status:	RAM has been failed because: Wrong Access Code	

Digital Certificate Holder: cn=Scott Joseph Asmus,ou=Registered Attorneys,ou=Patent and  
Trademark Office,ou=Department of Commerce,o=U.S. Government,c=US  
Certificate Message Digest: b7ede9103cf895f189b077a88623b5d1e9179781

PATENT APPLICATION SERIAL NO. \_\_\_\_\_

U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICE  
FEE RECORD SHEET

06/14/2004 GWORDOF1 00000008 190130 10710023

01 FC:1001 770.00 DA

PTO-1556  
(5/87)